



RABIN & BERDO, P.C.
*Specializing in Patent, Trademark
And Copyright Law*

Steven M. Rabin
Robert H. Berdo, Jr.
Phillip G. Avruch
Allen Wood
Qixia Zhang, Pat. Agent (China)

Suite 500, 1101 14th Street, N.W.
Washington, D.C. 20005
Tel.: (202) 371-8976 Fax: (202) 408-0924
E-Mail: firm@rabinchamp.com

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

March 12, 2004

Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attorney Reference: OKI 414

Re: New Patent Application of: Akira TAKAHASHI
Title: DRY ETCHING METHOD FOR SEMICONDUCTOR DEVICE

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (12 Pages)
- [x] 3 Sheets of Formal Drawings (Fig. 1 through Fig. 3c)
- [x] Inventor's Declaration and Power of Attorney (3 Pages)
- [x] Assignment document with cover page (2 Pages)
- [x] Claim for priority and the Priority document
- [x] Information Disclosure Statement, Form PTO-1449, and copies of 3 references
- [x] Form PTO-2038
- [x] Fee (see formula below)

Basic Fee \$770/385	\$ <u>770.00</u>
Additional Fees:	
Total number of claims: <u>5</u>	
in excess of 20: <u>0</u> times \$18/9	\$ <u>0.00</u>
Number of independent claims: <u>2</u>	
in excess of 3: <u>0</u> times \$86/43	\$ <u>0.00</u>
Multiple Dependent Claims \$290/145	\$ <u>0.00</u>
Recording Fee \$40.	\$ <u>40.00</u>
TOTAL FEES FOR THE ABOVE APPLICATION	\$ <u>810.00</u>

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2003-334784, filed September 26, 2003.

Respectfully submitted,

Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No. 23995)

RHB:tz

15535 U.S. PTO
10/798482

